



Attorney's Docket No.: 4936 USA/ETCH/METAL/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent
RECEIVED
FEB 03 2004
TC 1700

In Re Application of:

Steven Verhaverbeke et al.

U.S. Serial No: 09/945,454

Filed: August 31, 2001

For: A METHOD AND APPARATUS
FOR PROCESSING A WAFER

Examiner: Moore, Karla A.

Art Unit: 1763

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Final Office Action mailed August 25, 2003 and the Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 filed concurrently herewith. Applicant respectfully requests the Examiner to enter this Amendment and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP _____

COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450

U.S. Patent and Trademark Office, Washington, D.C. 20231 on Monday, January 26, 2004

Date of Deposit

Teresa Edwards

Name of Person Mailing Correspondence

Teresa Edwards

Signature

January 26, 2004

Date